

1752

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaru MITSUI et al.

Application No.: 09/509,472

Filed: April 21, 2000

For: PHOTOMASK BLANK, PHOTOMASK, METHODS OF MANUFACTURING THE  
SAME AND METHOD OF FORMING MICROPATTERN

Group Art Unit: 1752

Examiner: Y. Thornton

Docket No.: 105875

**SUPPLEMENTAL AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

As a supplement to the Amendment filed on September 17, 2003, please further

consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**